



PATENT
RECEIVED
JAN 16 2004
TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

: 10/019,056

Confirmation No.

: 1734

Applicant

: KIYOSHI DEMIZU, et al.

Filed

: April 22, 2002

TC/A.U.

: 2811

Examiner

: Tran, Thien F.

Docket No.

: 029368.50674US

Customer No.

: 23911

Title

: SEMICONDUCTOR WAFER AND DEVICE FOR
SEMICONDUCTOR DEVICE MANUFACTURING
PROCESS

REPLY TO OFFICE ACTION

Mail Stop: Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the Office Action dated October 15, 2003.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

RECEIVED
JAN 21 2004

TECHNOLoGy CENTER 2800